

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of MAJIMA et al

Application No.

Examiner:

Filed: (Herewith)

Group Art Unit:

For: POROUS SILICON CARBIDE SINTER AND SILICON CARBIDE-METAL  
COMPOSITE THAT ARE OPTIMAL FOR A WAFER GRINDER TABLE

PRELIMINARY AMENDMENT

Box Patent Applications  
Commissioner for Patents  
Washington, D.C. 20231

Sir:

Prior to examination on the merits, please amend the above-identified application as follows:

IN THE SPECIFICATION:

On page 1, line 1, delete the heading "SPECIFICATION"

On page 1, line 6 delete the heading "TECHNICAL AREA" and replace it with - - -  
BACKGROUND OF THE INVENTION - -

On page 1, line 16, delete the heading "BACKGROUND ART"

On page 5, line 22, delete the heading "DISCLOSURE OF THE INVENTION and  
replace it with - - SUMMARY OF THE INVENTION - -